What is claimed is:

- 1 1. An apparatus comprising:
- an embossable substrate mixture that includes a polymer and a release agent.
- 1 2. The apparatus of claim 1, further including:
- a substrate base, wherein the embossable substrate mixture is a film over the
- 3 substrate base and is embossed.
- 1 3. The apparatus of claim 2, wherein the embossable substrate mixture is a film
- over a Mylar film that is attached to the substrate base.
- 1 4. The apparatus of claim 1, wherein the embossable substrate mixture polymer
- 2 comprises:
- an epoxy resin; and
- 4 a hardening agent.
- The apparatus of claim 4, wherein the release agent comprises carnauba wax.
- 1 6. The apparatus of claim 5, further comprising:
- 2 metal wiring deposited in embossed grooves of the embossable substrate
- 3 mixture;
- one or more electronic chips coupled to the metal wiring; and
- one or more external electrical connections coupled to the metal wiring.
- The apparatus of claim 6, wherein the one or more electronic chips attached
- to the metal wiring includes a computer processor; the apparatus further comprising:
- a memory operatively coupled to the processor;
- an input system and an output system operatively coupled to the processor;
- 5 a power supply operatively coupled to the processor; and

- an enclosure holding the processor, the memory, the input system, the output system, and the power supply.
- 1 8. The apparatus of claim 1, wherein the release agent comprises one or more
- 2 components selected from the group consisting of montanic acid, stearic acid,
- myristic acid, and combinations thereof.
- 1 9. The apparatus of claim 1, wherein the release agent comprises one or more
- 2 components selected from the group consisting of fatty acid glycol esters,
- polyethylene glycol esters, laurate ester and combinations thereof.
- 1 10. The apparatus of claim 1, wherein the release agent comprises one or more
- 2 components selected from the group consisting of microcrystalline wax, urethanized
- 3 microcrystalline wax and oxidized microcrystalline wax and combinations thereof.
- 1 11. The apparatus of claim 1, wherein the release agent comprises one or more
- 2 components selected from the group consisting of polyethylene waxes, urethanized
- polyethylene and oxidized polyethylene wax and combinations thereof.
- 1 12. The apparatus of claim 1, wherein the release agent comprises one or more
- 2 components selected from the group consisting of low-molecular-weight branched
- polyethylene, oxidized low-molecular-weight branched polyethylene, silicone, amino
- 4 functional polydimethylsiloxanes, and combinations thereof.
- 1 13. The apparatus of claim 1, wherein the substrate mixture comprises:
- 2 methyl ethyl ketone;
- 3 digylcidyl Bisphenol-A;
- 4 tetrabromo Bisphenol-A;
- ortho-cresol novolak epoxy resin;
- 6 epoxy-terminated polybutadiene rubber;

- 7 brominated phenolic novolak resin;
- 8 2,4-diamino-6-(2-methyl-1-imadizolylethyl)-1,3,5-triazine.isocyanuric acid adduct;
- 9 silica; and
- 10 carnauba wax.
- 1 14. The apparatus of claim 1, wherein the substrate mixture has a composition
- 2 ratio of approximately:
- 3 210 parts of methyl ethyl ketone;
- 4 20 parts of digylcidyl Bisphenol-A;
- 5 20 parts of tetrabromo Bisphenol-A;
- 6 20 parts of ortho-cresol novolak epoxy resin (215 g/eq);
- 7 15 parts of epoxy-terminated polybutadiene rubber;
- 8 50 parts of brominated phenolic novolak resin;
- 9 4 parts of 2,4-diamino-6-(2-methyl-1-imadizolylethyl)-1,3,5-triazine.isocyanuric
- 10 acid adduct;
- 11 l parts of silica (maximum particle size of 5 microns); and
- 12 1 part of carnauba wax.
- 1 15. The apparatus of claim 14, further comprising:
- 2 metal wiring deposited in embossed grooves of the embossable substrate
- 3 mixture;
- one or more electronic chips coupled to the metal wiring, wherein the one or
- 5 more electronic chips form a computer processor;
- one or more external electrical connections coupled to the metal wiring;
- 7 a memory operatively coupled to the processor;
- an input system and an output system operatively coupled to the processor;
- a power supply operatively coupled to the processor; and
- an enclosure holding the processor, the memory, the input system, the output
- system, and the power supply.

- 1 16. A method comprising:
- 2 providing a substrate base; and
- depositing a film of an embossable mixture that includes a polymer and a
- 4 release agent over the substrate base.
- 1 17. The method of claim 16, wherein the depositing of the film includes forming
- a layer of the embossable mixture over a Mylar film, and attaching the Mylar film to
- 3 the substrate base.
- 1 18. The method of claim 16, wherein the providing of the embossable mixture
- 2 comprises:
- mixing an epoxy resin and a hardening agent with the release agent.
- 1 19. The method of claim 18, wherein the release agent comprises carnauba wax.
- 1 20. The method of claim 19, further comprising:
- embossing a plurality of grooves into the embossable mixture layer;
- depositing metal into the embossed grooves;
- 4 removing excess metal to leave wiring traces;
- 5 coupling one or more electronic chips to the metal wiring; and
- 6 coupling one or more external electrical connections to the metal wiring.
- 1 21. An apparatus comprising:
- a substrate base; and
- means attached to the substrate base for providing an embossable surface
- with reduced adherence properties to an embossing tool.
- 1 22. The apparatus of claim 21, wherein the means for providing the embossable
- 2 surface includes a polymer film having attached thereto means for releasing the
- 3 embossing tool mixed with an epoxy resin.

- 1 23. The apparatus of claim 22, wherein the means for releasing the embossing
- 2 tool comprises carnauba wax.
- 1 24. The apparatus of claim 23, wherein the means attached to the substrate base
- for providing the embossable surface is embossed, wherein the apparatus further
- 3 comprises:
- 4 metal wiring deposited in embossed grooves of the embossable surface;
- one or more electronic chips coupled to the metal wiring, wherein the one or
- 6 more electronic chips form a computer processor;
- one or more external electrical connections coupled to the metal wiring;
- a memory operatively coupled to the processor;
- an input system and an output system operatively coupled to the processor;
- a power supply operatively coupled to the processor; and
- an enclosure holding the processor, the memory, the input system, the output
- system, and the power supply.
- 1 25. A method comprising:
- 2 providing a substrate having a surface film of an embossable mixture that
- includes a polymer and a release agent on the substrate base;
- 4 embossing a plurality of grooves into the embossable mixture layer;
- 5 depositing metal into the embossed grooves; and
- 6 removing excess metal to leave wiring traces.
- 1 26. The method of claim 25, wherein the providing of the substrate includes
- 2 providing a substrate base and a surface layer of embossable mixture on a Mylar
- film, and attaching the Mylar film to the substrate base.
- The method of claim 26, wherein the providing of the surface layer of the
- embossable mixture comprises mixing an epoxy resin and a hardening agent with the
- 3 release agent.

The method of claim 27, wherein the release agent comprises carnauba wax. 28. 1